

DOCKET NO: 285995US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KOHEI KAWAMURA, ET AL. : EXAMINER: PARENDO, KEVIN A.
SERIAL NO: 10/567,733 :
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823
FOR: METHOD FOR FORMING FILM, :
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT SYSTEM

RESPONSE TO RESTRICTION AND ELECTION OF SPECIES REQUIREMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

The Office Action mailed September 18, 2008, contained both a Restriction requirement and an Election of Species requirement. In response to the Restriction requirement, Applicants elect, without traverse, Invention I corresponding to Claims 1-12 and 14-15. In response to the Election of Species requirement, Applicants elect, without traverse, Species A and identify Claims 1-9 as readable on elected Species A.

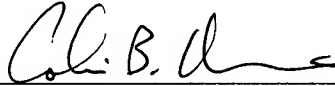
Applicants make these elections based on the understanding that Applicants are not prejudiced against filing one or more divisional applications that cover the non-elected claims.

Accordingly, Applicants respectfully request an early and favorable action on Claims

1-9.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
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